



Docket 80236A/PCW  
Customer No. 01333

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Ramanathan Srinivasan, et al

SLURRY FOR CHEMICAL  
MECHANICAL POLISHING  
SILICON DIOXIDE

Patent No. 6,491,843B1

Issued 12-10-2002

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA. 22313-1450

Assignee: Eastman Kodak Company

I hereby certify that this correspondence is being deposited today with the United States Postal Service as first class mail in an envelope addressed to Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

*Maria Langschwager*  
Maria Langschwager

*May 25, 2004*  
Date

Certificate

JUN 6 2004

of Correction

Sir:

**REQUEST FOR CERTIFICATE OF CORRECTION**  
**UNDER RULE 322**

Request is hereby made on behalf of the inventor and assignee that hereinafter-identified mistakes in the above-identified patent can be corrected by issuance of a Certificate of Correction. Such mistakes occurred in some instances as a result of the fault of the Patent Office.

The location of such mistakes in the patent, and of the corresponding correct language in the application, are as follows:

Patent Reference

Column 12, claim 1, line 21  
Column 12, claim 7, line 44

Application Reference

Page 19, claim 1  
Page 19, claim 7

The Director is hereby authorized to charge any fees in connection with this communication to Eastman Kodak Company Deposit Account No. 05-0225.

**A duplicate copy of this letter is enclosed.**

Respectfully submitted,

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JUN 02 2004

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
CERTIFICATE OF CORRECTION**

**PATENT NO.:** 6,491,843 B1  
**DATED:** 12-10-2002  
**INVENTOR(S):** Ramanathan Srinivasan, et al

It is certified that an error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 12, claim 1, line 21	Please replace the word "silicone" with the word --silicon--
Column 12, claim 7, line 44	Please replace "HN <sub>3</sub> " with --HNO <sub>3</sub> --

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 6,491,843 B1  
DATED : December 10, 2002  
INVENTOR(S) : Ramanathan Srinivasan et al

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

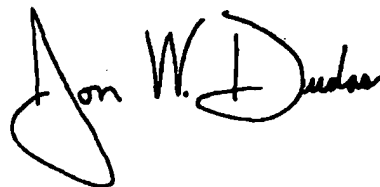
Column 12.

Line 21, please replace the word "silicone" with the word -- silicon --

Line 44, please replace "HN<sub>3</sub>" with -- HNO<sub>3</sub> --

Signed and Sealed this

Thirteenth Day of July, 2004

A handwritten signature in black ink, appearing to read "Jon W. Dudas". The signature is stylized with a large, looped initial "J" and a distinct "D".

JON W. DUDAS  
*Acting Director of the United States Patent and Trademark Office*